

ABSTRACT OF THE DISCLOSURE

A ceramic material coating method of forming a coating film on a base by applying a ceramic material including a complex oxide to the base by spin coating, the
5 method includes: a first rotational step of rotating the base at a predetermined rotational speed; a second rotational step of rotating the base at a rotational speed lower than the rotational speed in the first rotational step; and a third rotational step of rotating the base at a rotational speed higher than the rotational speed in the second rotational step.